MEMS Deformable Mirror Technology for Exoplanet Imaging Instrumentation

Exoplanet Imaging and Characterization: Coherent Differential Imaging and Signal Detection Statistics - Part 2 December 5 - 8, 2016 California Institute of Technology - Pasadena, CA 91125





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Outline

- BMC DM Technology
- Mirror technology programs
- Space qualification programs
- DMs in telescopes
 - Ground
 - Space
- Next steps for scaling DM actuator count



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BMC DM Technology

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MEMS DM Architecture



Continuous mirror (smooth phase control)



Segmented mirror (uncoupled control)



Deflected Actuator



Deformed Mirror Membrane



Deformed Segmented Mirror

MEMS DM Fabrication

(deposit, pattern, etch, repeat)





MEMS DM Fabrication

(deposit, pattern, etch, repeat)



<u>Electrodes & wire traces</u>: polysilicon (conductor) & silicon nitride (insulator)



Space $5\mu m$



Mirror membrane: oxide (spacer) and polysilicon (mirror)



<u>MEMS DM</u>: Etch away sacrificial oxides in HF, and deposit reflective coating



Attach die to a ceramic package and wirebond



BMC Mirror Family

Small Cartesian Arrays

- Square arrays from 32 to 140 actuators
- Strokes: 1.5μm, 3.5μm or 5.5μm

Medium Cartesian Arrays

- Square and circular arrays from 492 to 1020
- 1.5µm & 3.5µm stroke

Large Cartesian Arrays

- Square and circular arrays from 2040 to 4092
- 1.5μm and 3.5μm stroke
- Hex Tip-Tilt-Piston
 - 37, 331- and 1021-Segment Devices





Hex Tip-Tilt-Piston Deformable Mirror







- Up to 3063 actuators
- Independent hexagonal segments
 - 3 actuators per segment





- 4 µm max. stroke
- 7 mrad max. tilt angle







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Funded Technology Research

Over the past years BMC has received funding for the improvement of MEMS DM for space applications

- Topography
- Yield
- Reliability
- Reduced operating voltage
- Hex TTP development

Topography Improvements



Heritage Process



Modified Process



Scalloping across mirror compared to heritage devices



Note 3064 aperture is 17mm while heritage is 10mm

Topography Improvements





Unpowered Surface

With low order filtered (control bandwidth)

Reduction in Operating Voltage (Ongoing)







Modified design allows full actuation at lower voltage

Reduced Operating Voltage

- Lower power usage
- Easier electronics
- Safer operation



Enhanced Reliability Concept



Actuator Design



Deflection versus voltage. Initial, after cycling 3 million times above critical voltage (295V).



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TDEM Program



Ongoing Contract#: NNH12CQ27C TDEM/ROSES MEMS Deformable Mirror Technology Development for Space-Based Exoplanet Detection

Objective: Demonstrate survivability of the BMC MEMS Deformable Mirror after exposure to dynamic mechanical environments close to those expected in space based coronagraph launch.

9 Mirrors ready for testing



5cm



Project Flow



12 DMs Fabricated and Characterized





Single Actuator Surface Figure



Delivered to JPL (2) and Princeton (2)



Sinusoid Shape

4 Period, 400nm Amplitude





Vacuum Surface Gauge (VSG) Measurements

Two 952 a separatel

- Surface fi
- Surface fi
- Actuator up/down conditior
- Drift in superiod
- Repeatak for 10 repeats





BMC Engineering DM, unpowered –

- Zernike fit to the central actuators to the diameter = 34 actuators
- 37 zernikes removed
- Residual high order surface beyond z37 = 18nm rms = 130 PV



Influence Function Measurements, BMC DM1

 Average of 20 individual pokes, 42 volt pokes over 50 volt bias

> John Trauger, Frank Greer 9/30/2016



leNe laser ezo-driven

• Deformable mirror under test is on a gimbal mount with a temperature controlled stage





High Con

Recent Lab Results

- Stroke minimization controller
- Two BMC DMs with 952 actuators on each
- Achieved 3 x 10⁻⁷ contrast within 30 iterations 5.5-10.5 λ/D Initial Image
 Final Image





Image Credit: Groff & Kasdin 2013

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= 80 inch Insging

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On-Sky Instruments using BMC Mirrors



ROBO-AO

• <u>Multi-DM</u> Installed Palomar 2011/ Moved to Kitt Peak 2015



SCExAO, Subaru telescope

• <u>2040</u> installed 2013



Shane-AO, Lick Observatory

- Kilo-DM installed 2013
- Visible Light Laser Guidestar Experiments





Shane AO off Shane AO on Portion of the M92 globular cluster taken in H band.

Gemini Planet Imager, Gemini South

<u>4092</u> installed 2013
 Beta Pictoris b





THE PICTURE(-B) SOUNDING ROCKET

PI: Supriya Chakrabarti, UMASS Lowell November 2015

- **Reflected light from Exoplanets**
- Scattered Light from Exozodi
- Visible Light Coronagraphy (in space)
- Active wavefront control



DOUGLAS 2016, COURTESY UML

The DM was powered in flight. Deformable mirror "flat" map applied in flight to remove curvature:

Flat *Flight* Wavefront Sensor Measurements of Pupil Plane Fringes:











Telescope

Instrument

Electronics

22.5 20.0 17.5

10.0





Cubesat: Deformable Mirror Demonstration Mission (DeMi)

PI: John Merk, Aurora Flight Systems, Keri Kahoy, MIT

- Validate and demonstrate the capabilities of high actuator count MEMS deformable mirrors for high contrast astronomical imaging.
- Characterize MEMS deformable mirror operation using both a Shack Hartmann wavefront sensor as well as sensorless wavefront control.





Eace Telecommunications, Intronomy, and Radiation Lab









EXoplanetary Circumstellar Environments and Disk Explorer (EXCEDE) **Final Broadband Milestone Results**



200

2000









Lockheed Martin Vacuum Chamber

 $\lambda_0 = 650$ nm, Bandwidth = 10%

- Test A

Time interval: 67 min 1.2- 2.0 λ_0 /D: 1.35x10⁻⁵ $2.0-11.0 \lambda_0/D: 2.82 \times 10^{-7}$

- Test B

Time interval: 816 mins 1.2- 2.0 λ_0 /D: 1.29x10⁻⁵ $2.0-11.0 \lambda_0$ /D: 3.14×10^{-7}

- Test C

Time interval: 61 mins 1.2 – 2.0 λ_0 /D: 1.33x10⁻⁵ $2.0-11.0 \lambda_0/D: 2.63 \times 10^{-7}$





EXCEDE Proposing for the 2016 MidEX AO



- Technical specs:
 - 0.7m primary, TMA unobstructed optical telescope
 - PIAA Coronagraph
- Mission overview
 - Survey of ~ 350 nearby exoplanetary systems
- Science Capabilities
 - Circumstellar debris systems including the habitable zone
 - Gas giants (if sufficiently bright)



1K Boston MEMS DM Outer Working Angle – 15 L/D



Outer Working Angle – 31 L/D







Large UV/Optical/Infrared Surveyor

- Deformable mirror needs
 - 10k+ actuators
 - Space qualified
 - TRL 6
 - .
- Instrument Components subgroup of the Technical Working Group
- Targeted Performance
- Demonstrated Performance
- Technology Readiness Levels





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Need for Even Higher Actuator Count DM (10k +)

- For many next generation instruments, more actuators are needed
- Limited by electrical interconnects
 - Wirebond for each actuator
 - Span of active optical surface scales with N
 - Span of the chip scales with N²
 - Limits number of die on a wafer
 - Increases the likely hood of a single point defect causing short/failure



Proposed Architecture (Concept)





Proposed Architecture (Concept)





Through-Wafer-Via DM Fabrication Prototype

New process (and new foundry for manufacturing) relies on BMC heritage actuator and mirror design, but eliminates wire bonds and instead uses through-wafer-via (TWV) technology

TWV is single crystal silicon: exceptionally low defect level allows major increase in device yield and reliability

Manufacturing challenge is shifted to packaging of TWV devices

In prototype project, 140 actuator, 500 actuator, and 2000 actuator devices were fabricated and tested



Sacrificial Oxide (PSG)

Poly Silicon

Gold Pad



Flex cable packaging of 2000 actuator TWV devices

Polymer bump bonds

Chip and cable curvature over large area device diminished bond yield (~70%)

Testing of well-bonded sections yielded reliable actuation performance







Proposed Architecture (Concept)





Electronics Design









•The controller has a volume of 90mm (w) x 90mm (l) x 54.6mm (h), w/o mirror and socket.

•It only requires a 12V power supply and consumes 6W.

- •USB interface for data
- •0-215V, 16 bits
- •Scalable technology for greater channel count

Conclusion



- MEMS DM have been proven in astronomical instrumentation
- Continued technology development is ongoing
- Poised for next generation instruments, but development needs to occur.



Thank You

Questions?



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